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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Im-soo PARK, et al	Art Unit: 1746
Serial No.: 10/685,515	Examiner: Saeed T. Chaudhry
Filed: October 16, 2003	*Confirmation No.: 8169*
For: APPARATUS FOR CLEANING SEMICONDUCTOR WAFER INCLUDING HEATING USING A LIGHT SOURCE AND METHOD FOR CLEANING WAFER USING THE SAME (AS AMENDED)	Attorney Docket No.: 249/255 DIV

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop: BOX AF
Commissioner for Patents
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action Made Final, dated January 9, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

Amendments to the Claims are reflected in a listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.